

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of)	
)	
Tetsuro Inui et al.)	
)	
Serial No.:)	Art Unit
10/624,082)	2613
Filing Date:)	
July 21, 2003)	
Confirmation No.:)	
5995)	
For:)	
DISPERSION MONITORING METHOD AND)	
APPARATUS AND DISPERSION SLOPE)	
TEMPERATURE DEPENDENCY COMPENSATION)	
METHOD AND APPARATUS)	
Examiner:)	
Hibret Asnake Woldekidan)	

AMENDMENT "D" AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Examiner:

Applicant submits this paper in response to the Office Action mailed July 23, 2009.
Reconsideration is respectfully requested in view of the following remarks:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 8 of this paper.